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Characterization of a Quarter Torus Filter for Vacuum Arc Ion Flux Transmission

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Measurements on the ion flux transmission in a magnetically filtered d-c vacuum arc are presented. The device includes a metallic plasma-generating chamber with water-cooled electrodes coupled to a substrate chamber through a quarter-torus magnetic filter. It is employed a Copper cathode (6 cm in diameter) with a Copper annular anode. The filter consists in a steel cylinder 500 mm length and 100 mm inner diameter with 90° of bending angle and corrugated lateral walls, surrounded by a magnetic field generating coil. The arc is operated at a current level of 100 A, and the intensity of the filtering magnetic field was in the range 0-200 G (measured at the knee of the filter). This magnetic field is enough high so as to magnetize the electrons but not the ions. The discharge is ignited by bringing (and later removing) a tungsten striker into contact with the cathode. The arc voltage drop, the floating potentials of the filter and the plasma, and the ion current collected by probes located at different positions as functions of the magnetic field intensity are reported and compared with measurements presented in the literature with other similar devices.

1 Introduction

The cathodic vacuum arc is widely used to produce coatings[1]. The deposited material comes from highly ionized plasma ejected from minute sizes on the cathode surface, known as cathode spots. The kinetic energies of the ions are in the range 15-120 eV, depending on the cathode material and on the charge-state of the ion[2, 3], and with a total ion current amounting to 8-10 % of the total discharge current[4].

The presence of microdroplets of melted cathode material in the coatings is a disadvantage in vacuum arc technology, since for some applications this macrodroplets increase the porosity and roughness of the coating. Several attempts have been made to separate the metallic plasma from the microdroplets by means of different filtering systems. The most popular of these systems are based on a focusing magnetic field that magnetize the electrons and guide the metallic plasma through the filter to the substrate but leave unchanged the microdroplet flux [5]. Unfortunately, part of the plasma flux is lost in the filter; so many efforts have been devoted to the optimization of filters that is removing all the microdroplets with the minimum losses of plasma. Straight [6, 7, 8] and curved[5, 9, 10] filters have been studied. Presently, the one most often employed in practice is the so-called "quarter torus filter" (developed by Aksenov). It consists in a circular non-magnetic metallic tube with a bending angle of 90°, and with a toroidal magnetic field generated by an external coil. The magnetic field intensity is in the range 50 - 500 G, a value enough high to magnetize the plasma electrons. One of the most important findings in a quarter torus filter optimization consisted in applying a positive bias voltage (with respect to the plasma potential) of about $10-20~\rm V$ to the filter.

In this work we present the first measurements performed with a magnetically filtered arc at INFIP (DCF2 device). The arc voltage drop and the floating potential of the filter as functions of the magnetic field intensity are reported. By employing also ion collectors, measurements of the ion flux transmission and plasma floating potential for different biasing voltages of the filter are reported and discussed.

2 Experimental setup

The investigations were carried out in a d-c filtered vacuum arc system, which is shown schematically in Fig. 1. There is a plasma generation chamber that includes a water-cooled copper cylindrical cathode (60 mm in diameter) surrounded by a floating shield, an annular water-cooler cooper anode (80 mm in diameter), and a tungsten striker which is brought into contact with the cathode surface and later removed to trigger the discharge. Both electrodes are mounted on an insulating piece that set an electrode separation of about 15 mm. The anode was grounded. At the exit of this chamber is connected a magnetic quarter torus filter (500 mm length, 100 mm inner diameter) made of corrugated stainless steel, including an external coil which produces the filtering magnetic field. The bending angle of the torus is 90°.

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At the exit of the torus a deposition stainless steel vacuum chamber (cross shaped) is connected. The electrodes system, magnetic filter and deposition chamber are electrically isolated among them. By employing an independent d-c power source, the magnetic filter can be biased with respect to the anode. Two vacuum systems (composed of mechanical and diffusion pumps) pump separately the plasma generation and deposition chambers to a base pressure of less than 10^{-4} mbar. The discharge circuit consisted in a current supply (18 kW, 150 A) in parallel with a capacitor bank (165 mF) connected to the electrodes through a series inductor (2.8 mH) in order to provide arc stability. The arc was operated in a continuous mode with an arc current of 100 A.

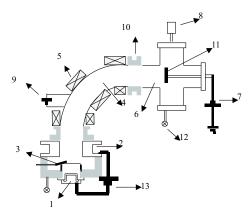


Figure 1. Scheme of the DCF2 device. (1) cathode; (2) anode; (3) trigger; (4) quarter torus magnetic filter; (5) torus coil; (6) deposition chamber; (7) probe bias source; (8) diagnostic port; (9) filter bias source; (10) insulators; (11) collecting probe; (12) vacuum pumping systems; (13) arc source.

The magnetic field generating coil was fed by an independent d-c variable current source, so that magnetic field values (measured by a Hall probe) varied in the range 0-197 G. The maximum field corresponded to a coil current of 55.2 A, and was obtained at the knee of the torus.

The anode-cathode voltage drop was measured using a high impedance resistive voltage divider. The ion current at the exit of the filter was sensed introducing different sized collecting probes (probe A with a collecting area of 57 cm², and probe B with a collecting area of 7.6 cm²) at different positions in the deposition chamber. The probes were biased at different voltages by a d-c power source, and the collected current was registered by measuring the induced voltage drop on a resistor connected in series with the biasing power source. Two high-impedance resistive voltage dividers were also employed to register the floating potentials of both the collecting probe and the filter. The electrical signals were registered in a four channel digitizing oscilloscope (sampling rate of 250 Ms/s, analogical bandwidth of 500 MHz).

3 Results

In Fig. 2 a typical magnetic field (B) profile is shown. The independent variable is the azimuthal angle of the torus ϕ ,

measured with respect to its center of curvature ($\phi=0^{\circ}$ coincides with the filter entrance, $\phi=45^{\circ}$ coincides with the filter knee and $\phi=90^{\circ}$ coincides with the filter exit). The coil current in Fig. 2 was 33 A, given a maximum field at the knee (B_k) of 120 G. It can be seen that the magnetic field is strongly inhomogeneous, and it drops at ~ 10 % of its maximum value (B_k) at the filter exit. Other coil currents gave similar shaped B profiles, since B is proportional to the coil current. In what follows, we will use the maximum value B_k to characterize the magnetic state of the filter.

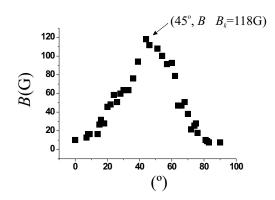


Figure 2. Magnetic field profile as a function of the azimuthal angle ϕ , for a coil current of 33 A; the maximum value of B (at the knee of the quarter torus) is $B_k=118~\mathrm{G}$.

The arc voltage drop resulted independent of the magnetic field value and the filter bias operating conditions. For an arc current of $100~\rm A$ it took a value of $(20\pm2)~\rm V$.

The floating potentials (with respect to the grounded anode) of the magnetic filter V_{ff} and the probe V_{fp} as functions of B_k , are shown in Fig. 3. The probe was located at 20 cm of the filter exit. Each point in the figure represents an average of 3-5 arc discharges performed under identical conditions. An individual measurement had a typical uncertainty of 10%, due to the inherent noisiness of the arc plasma. It can be seen from Fig. 3 that $V_{ff} < 0$ for $B_k < 75$ G ($V_{ff}(B_k=0)=-7V$) while it becomes positive for higher values of B_k . Since the plasma potential is quite close to the anode potential, a positive value for V_{ff} indicates a strong magnetization of the electrons. On the other hand, V_{fp} is always negative, and shows a complex behavior with B_k , presenting a kind of "potential well". In fact, V_{fp} varies from -12 V at $B_k = 0$ to -40 V at $B_k \sim 30$ G, and then slowly increases with B_k , reaching the value V_{fp} ($B_k = 197$ G) = -22 V. It should be emphasized that the actual B value at the probe position (B^*) is in this experiment much smaller than the conventional B_k value at the torus knee. For this reason, both values of B (B_k and B^*) have been plotted in the abscissa axis of Fig. 3.

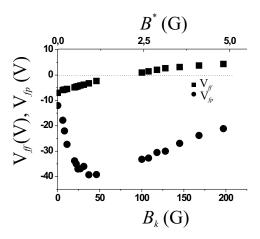


Figure 3. V_{ff} and V_{fp} as functions of the magnetic field at the filter knee B_k (or equivalently, the magnetic field at the filter exit B^*) with the probe located at L = 20 cm from the filter exit.

To study the influence of the probe on the filter floating potential, V_{ff} was measured for different biasing voltages of the probe (V_{bp}) . The results are presented in Fig. 4, where V_{ff} is plotted against B_k for $V_{bp} = -50$ V, $V_{bp} = -30$ V and $V_{bp} = V_{fp}$. It can be seen from Fig. 4 that for small values of B_k (when $V_{ff} \le 0$) there is no clear dependence of V_{ff} on V_{bp} , but for high values of B_k ($B_k > 120$ G) V_{ff} slightly increases with the absolute value of V_{bp} .

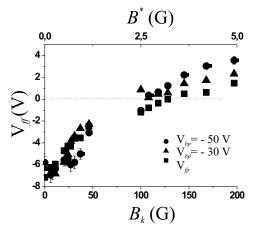


Figure 4. V_{ff} as a function of the magnetic field at the filter knee B_k (or equivalently, the magnetic field at the filter exit B^*), at different probe voltages (V_{bp} and V_{fp}) for probe A, with L=20 cm.

In Fig. 5, the larger size probe current $I_{p \rm A}$ as a function of B_k , for different probe bias potentials ($-50~{\rm V}$ and $-30~{\rm V}$) and floating filter is presented. For $V_{bp}=$ -50 V, $I_{p \rm A}$ is negative for low B_k values, and increases with B_k , reaching positive values for $B_k > 30~{\rm G}$. The situation for $V_{bp} = -30~{\rm V}$ is quite similar to the previous one, but in this case $I_{p \rm A}$ reaches positive values for $B_k > 140~{\rm G}$. The negative values of $I_{p \rm A}$ registered for low B_k values are consistent with the high negative V_{fp} values shown in Fig. 3.

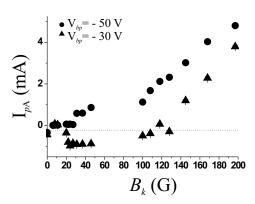


Figure 5. Probe current $I_{p\mathbb{A}}$ for floating filter as a function of the magnetic field at the filter knee B_k at different V_{bp} values, with L=20 cm.

A comparison between the ion current collected by probes of different sizes is presented in Fig. 6. Both probes were located at 20 cm from the duct exit, biased at -50 V and with floating filter. The quotient between both currents coincides approximately with the quotient between the probe's areas, indicating a good homogeneity of the plasma at the probe's position.

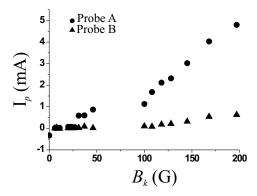


Figure 6. Probe current for floating filter as a function of the magnetic field at the filter knee B_k , with different probe sizes, V_{bp} = -50~V and L=20~cm.

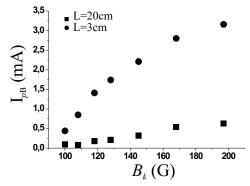


Figure 7. Probe current I_{PB} for floating filter as a function of the magnetic field at the filter knee B_k at different positions from the filter exit (L = 3 cm and 20 cm); with $V_{bp} = -50$ V.

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In order to investigate the plasma expansion at the filter's exit, I_{pB} was registered at different distances from the filter. This is shown in Fig. 7, where I_{pB} is plotted as a function of B_k for $V_{bp}=-50$ V, floating filter, and L=3 and 20 cm, being L the axial distance between probe and filter's exit. It can be seen that the shorter distance results in an increased I_{pB} value (by a factor of \sim 6). For $B_k=197$ G, the magnetic fields at both probe locations are: B^* (L = 3 cm)= 30 G and B^* (L = 20 cm)= 5 G.

Figure 8 shows the curve $I_{p\mathtt{A}}$ vs. B_k for different filter bias voltages (V_{bf}) , for $V_p = -50$ V. Each point in Fig. 8 represents the average of several runs (typically 3-5) performed under identical values of V_{bf} and B_k . In practice, the value of V_{bf} could not be fixed "a priori" because the electron current collected by the filter produced a considerable voltage drop in the inner resistance of the biasing power source, thus resulting in a true V_{bf} equal to the prescribed biasing voltage minus the resistive source voltage drop. For arcs performed under the same nominal biasing filter voltages, the above-described effect resulted in the obtainment of a range of V_{bf} values (typically with an uncertainty of ± 0.5 V). It can be seen that I_{pA} increases with B_k . For low values of B_k ($B_k < 85$ G) negative values of I_{pA} are found for V_{bf} values close to the filter floating potential (see Fig. 3). Note that the maximum V_{bf} value in Fig. 8 is $V_{bf} = 6$ V. This is due to the fact that the filter, when biased positively, collects a considerable negative current from the main arc discharge. In practice, with the presently available bias source, it was not possible to raise the bias voltage beyond 6 V, because the biasing power source of the filter cannot withstand a current larger than ≈ 20 A. The amount of this current is strongly dependent on V_{bf} (see next Figure).

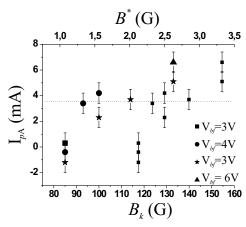


Figure 8. Probe current I_{pA} as a function of the magnetic field at the filter knee B_k (equivalently, the magnetic field at the filter exit B^*) at different V_{bf} values and $V_{bp} = -50$ V, with L = 20 cm.

Figure 9 shows the probe current I_{ph} and the current collected by the filter I_f , as functions of V_{bf} for $B_k=154~\rm G$ and $V_{bp}=-50~\rm V$. Each point in the figure represents the average of several runs (typically 3-5) performed under identical values of the nominal bias voltage. Note that I_f is negative (which means an electron current) and strongly increases (in absolute value) with V_{bf} , indicating that the filter is acting as a secondary anode for the main discharge.

For instance, for $V_{bf} = 4$ V the filter collects 20 % of the discharge current for $B_k = 154$ G.

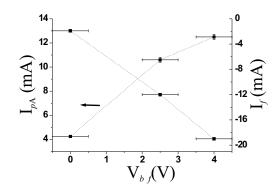


Figure 9. Probe current I_{pk} and filter current I_f as functions of the filter potential, with $V_{bp}=-50$ V, $B_k=154$ G and L=20 cm.

4 Discussion and final remarks

We have presented in this work the first measurements performed with a magnetically filtered arc at INFIP (DCF2 device). Although the optimization procedure is far from being complete (mostly due to the current limitation of the presently available filter bias source), the presented results show some interesting features.

The dependence of the filter floating potential with B_k is in agreement with previous published results by other authors [6, 9], being negative for small B_k values (when the electron flux reaching the filter still exceeds the ion flux) but becomes positive for high B_k values (when the electrons are strongly magnetized, and cannot reach the filter). The behavior of the probe floating potential with B_k presents some peculiarities never reported before, likely because of the small values of the magnetic field at the probe position (B^*) at which these peculiarities are produced: the presence of a deep "floating potential well" ($V_{fp} \sim -40$ V, corresponding to $B^* \sim 1$ G) when the electrons are partially magnetized (the electron Larmor radius is ~ 3 cm for $B^* \sim 1$ G and an electron temperature $T_e \sim 2$ eV) can be explained only in terms of changes in the plasma potential in the presence of B, in the electron distribution function, and/or changes in probe charge collection theory. Note that this "potential well" has important practical consequences, because a probe must be biased at voltages well below V_{fp} to collect a pure ion current.

The value of V_{fp} at B=0 can be safely employed to determine T_e , using classical electrostatic probe Langmuir theory corrected by Lam's work [11] to take into account ions of arbitrary kinetic energy. For $V_{fp}=-12$ V, assuming that the plasma potential at B=0 is close to the anode ground potential, and using published vacuum arc data on average kinetic energy and charge-state for Cu ions (40 eV and 1.8, respectively) [12], it is obtained $T_e=2.7$ eV, in agreement with other published data for arcs operating in vacuum [12]. It is also worth noting that V_{ff} at B=0 cannot be used to determine T_e , because probe theories cannot be used for an

object of large size where the embedded plasma changes its properties.

The Cu ion currents collected by the probes correspond to plasma densities of $10^8-10^9~{\rm cm}^{-3}$ at the filter exit, depending on the operating arc conditions. These densities produce a Debye length (that is of the order of the thickness of the plasma sheath at the filter wall) in the range of $0.3-1~{\rm mm}$ for $T_e=2.7~{\rm eV}$.

The best ion current collected at the filter exit amounts to ≈ 12 mA for $B_k = 154$ G, a value still small as compared with the maximum ion current ($\approx 8-10$ A) generated at the cathode surface for an arc discharge current of 100 A. The optimum ion current was obtained at a filter bias voltage of 4 V, when the filter, acting as a secondary anode, collected about 20 % of the main discharge current. This result indicates that to obtain an improvement in the ion transmission through the filter, the first task is to get a good matching between the plasma generation chamber and the filter entrance, which will be done in the near future by generating a focusing magnetic field in the cathode-filter region so as to optimize the ion flux entering into the filter. Also, it is necessary to increase the filter bias voltage by employing a power source with a higher current capacity. The strong decrease in the ion current as the probe-filter distance increases (see Fig. 7) indicates that it is also necessary to increase the magnetic field at the probe location.

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